

Category Filter	Category name	Process Step Name			Input Value		Author		
SiO2 Process (100% SiH4)	SiO2 Process (100% SiH4)	HDR SiO2 Dep 50C					NC		
Directory of Process Steps	Name	Setpoint	Units	Max	Min	Error+	Error-	Warn+	Warn-
HDR SiO2 Dep 50C	Process Time	270.0	s	3.1536E+07	0.0	0.0	0.0	0.0	0.0
	Pressure	5.0	mTorr			0.0	0.0	0.0	0.0
	Temperature1	40.0	degC	70.0	0.0	0.0	0.0	0.0	0.0
	Temperature2	50.0	degC	350.0	0.0	0.0	0.0	0.0	0.0
	Temperature3	40.0	degC	60.0	0.0	0.0	0.0	0.0	0.0
	HeliumCoolerPressureSetpoint	5000.0	mTorr	10000.0	0.0	0.0	0.0	0.0	0.0
	RF1 Mode	Power							
	RF1 DC Bias	0.0	volts	1000.0	0.0	0.0	0.0	0.0	0.0
	RF1 Forward Power	15.0	watts	600.0	0.0	0.0	0.0	0.0	0.0
	RF1 Reflected Power	0.0	watts	100.0	0.0	0.0	0.0	0.0	0.0
	RF2 Mode	Power							
	RF2 DC Bias	0.0	volts	2000.0	0.0	0.0	0.0	0.0	0.0
	RF2 Forward Power	800.0	watts	1000.0	0.0	0.0	0.0	0.0	0.0
	RF2 Reflected Power	0.0	watts	100.0	0.0	0.0	0.0	0.0	0.0
	AMN1 Mode	Auto							
	AMN1 Tune	46.0	%	100.0	0.0	0.0	0.0	0.0	0.0
	AMN1 Load	18.0	%	100.0	0.0	0.0	0.0	0.0	0.0
	AMN2 Mode	Auto							
	AMN2 Tune	40.0	%	100.0	0.0	0.0	0.0	0.0	0.0
	AMN2 Load	58.0	%	100.0	0.0	0.0	0.0	0.0	0.0
	He 500	0.0	sccm	750.375	0.0	0.0	0.0	0.0	0.0
	SiH4 100%	27.5	sccm	82.7473	0.0	0.0	0.0	0.0	0.0
	N2 500	0.0	sccm	519.0	0.0	0.0	0.0	0.0	0.0
	Ar 100	20.0	sccm	138.327	0.0	0.0	0.0	0.0	0.0
	O2 100	55.0	sccm	99.587	0.0	0.0	0.0	0.0	0.0
	N2 20	0.0	sccm	20.0747	0.0	0.0	0.0	0.0	0.0

	SF6 500	0.0	sccm	228.793	0.0	0.0	0.0	0.0	0.0
	Purge gas	0	sccm	536870911	0	0	0	0	0
	Camera Mode	none							
	Endpoint Detector	none							
	Past Point Time	0.0	s	3.1536E+07	0.0	0.0	0.0	0.0	0.0
	Endpoint Recipe	EP1.sw							
	Castum EndpointRecipe Name	EP1.sw							
	Overetch Step	FALSE							
	Overetch	0.0	%	1000	1	0.0	0.0	0.0	0.0
	Alarm on Endpoint Not Found	Default							